

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

**Title of  
Invention**

MAINTAINING UNIFORM CMP HARD MASK THICKNESS

Application Number :

Confirmation Number:

First Named Applicant: Shyng-Tsong Chen

Attorney Docket Number: FIS920040211US1

Art Unit:

Examiner:

Search string: ( 6358839 ).pn

### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
P2	1	6358839	2002-03-19	Li, et al.	—	—	—

### Signature

Examiner Name	Date
Phillip Sheen	12/12/2005

